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**CONFIRMATION NO. 4146** 

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** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
JAPAN 2000-173852 06/09/2000 JAPAN 2000-371828 12/06/2000 JAPAN 2000-379266 12/13/2000 JAPAN 2001-126415 04/24/2001							
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Foreign Priority claimed	yes no	STATE OR	SHEETS	тот	AL INDEPENDENT		
35 USC 119 (a-d) conditions met  Verified and Acknowledged	yes no Met after Allov	COUNTRY	DRAWING 20	CLAII 20			
ADDRESS ADAMS & WILKS ATTORNEY AND COUNSELORS AT LAW 31ST FLOOR 50 BROADWAY NEW YORK , NY							
TITLE  Method for forming aperture, near field optical head and method for fabricating the same and information recording/reading apparatus							
☐ All Fees							
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	S: Authority has been given in Pa	1.17 Fees ( Processing Ext. of time )					
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